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(REVERSE) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. APPLICATION NO. 930114.407 09/539,193						
			APPLICANTS						
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PAT & TRA	DEMA		U.S.	PATENT 1	DOCUMENTS				
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAME	CLASS	S SUBCLASS	FILING DATE IF APPROPRIATE	
ESP	AA	6,166,729	12/26/00	Acosta et al.		345	327		
USI	AB	6,201,356	03/13/01	Ushijima	et al.	315	282	· · · · · · · · · · · · · · · · · · ·	
CFF	AC	6,212,550	04/03/01	Segur		709	206		
40	AD	6,385,772	05/07/02	Courtney		725	105		
WF	AE	6,392,692	05/21/02	Monroe		348	143	143	
CLF	AF	6,412,004	06/25/02	Chen et al		709	226	41	
CHI	AG	6,412,008	06/25/02	Fields et a	ıl.	709	228		
WI	AH	6,452,355	09/17/02	Forster et	al.	318	569		
CAS	Al	6,453,355	09/17/02	Jones et a	l	709	230		
ST	AJ	6,457,052	09/24/02	Markowitz et al.		709	225		
			FOREI	GN PATEN	T DOCUMENTS				
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ROGER K. Brooks et al.
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GROUP ART UNIT

2155

March 30, 2000

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GI	AA	6,014,694	01/11/00	Aharoni et al.	709	219	
47	AB	6,292,834	09/18/01	Ravi et al.	709	233	
UF	AC	6,412,004	06/25/02	Chen et al.	709	226	
WF	AD	6,647,425	11/11/03	Chaddha	709	233	
CAI	AE	2003/0106063	06/05/03	Guedalia	725	90	
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